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| Application Serial No. | 09/234,233 |
|---|-------------------------|
| | January 20, 1999 |
| Inventor | Weimin Li et al |
| | Micron Technology, Inc. |
| | 2818 |
| | D. Vu |
| Attorney's Docket No | MI22-1035 |
| Title: Semiconductor Processing Methods | |

PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING

To:

Box RCE

Assistant Commissioner for Patents

Washington, D.C. 20231

From:

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REMARKS

This Request for Continued Examination (RCE) Application is being filed in an abundance of caution to permit consideration of a Supplemental Information Disclosure Statement.

No new matter is being presented in this application.

Respectfully submitted,

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Dated: 14 Nov 2001

By:

James E Lake

Reg. No. 44,854